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CONFIRMATION NO. 9573

SERIAL NUMBER 10/519,449	FILING OR 371(c) DATE 08/25/2005 RULE	C	CLASS GRO		OUP ART UNIT 2812		ATTORNEY DOCKET NO. SON-2782	
** CONTINUING DAT. This application ** FOREIGN APPLICATION JAPAN 2002-19	ra, Kanagawa, JAPAN; A ***********************************	.* 08377 07	7/01/2003					
Foreign Priority claimed			STATE OR COUNTRY JAPAN	SHEETS DRAWING 48		TOTAL CLAIMS 20		INDEPENDENT CLAIMS 3
TITLE Phase shift mask fabrication method thereof and fabrication method of semiconductor apparatus								
RECEIVED No	CEIVED No to charge/credit DEPOSIT ACCOUNT				☐ All Fees ☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of time) ☐ 1.18 Fees (Issue) ☐ Other ☐ Credit			